



11/2 AF

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **FUJIEDA, Tsukasa**

Group Art Unit: 1792

Serial No.: **10/576,277**

Examiner: **Robert S. WALTERS Jr.**

Filed: **April 18, 2006**

P.T.O. Confirmation No.: 9712

For. **METHOD OF FORMING LUSTER COATING FILM**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: August 11, 2009

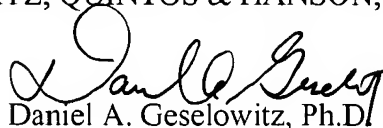
Sir:

Applicant petitions the Commissioner for Patents to extend the time for response to the Office Action dated April 14, 2009, for one month, from July 14, 2009, to August 14, 2009.

The Commissioner is authorized to charge our Deposit Account in the amount of \$130.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

KRATZ, QUINTOS & HANSON, LLP


Daniel A. Geselowitz, Ph.D.

Agent for Applicant
Reg. No. 42,573

08/12/2009 MAHME1 00000006 012340 10576277
01 FC:1251 130.00 DA

DAG/xl

Atty. Docket No. **060322**
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PATENT & TRADEMARK OFFICE